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Note: Editorial queries should be directed to: The Editor, Journal of Technology Studies, Technology Bldg., Bowling Green State University, Bowling Green, Ohio 43403, email: jots@bgsu.edu

Editorial Board

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230 Shay Building
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252.328.9673
battsdi@ecu.edu

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860.244.7608

Aaron C. Clark
Department of Math, Science & Technology Education
North Carolina State University
Box 7801, 510K Poe Hall
Raleigh, NC 27695
919.515.1717
aaron_clark@ncsu.edu

Jenny Daugherty
Technology Leadership and Innovation
Purdue University
Eustis C Young Hall, Room 443
West Lafayette, IN 47907
765.494.7989
jldaughe@purdue.edu

Jeremy V. Ernst
Department of Teaching and Learning
Virginia Polytechnic Institute and State University
315 War Memorial Hall
Blacksburg, VA 24061
540.231.2040
jeremy@vt.edu

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Staff for this Issue

Editorial Consultant
Lee Meiser

Publisher
Epsilon Pi Tau

Art & Layout
Knape Designs

Region 1 (The nations of Europe, the Eastern Provinces of Canada, and the Northeastern United States)
Thomas P. Bell
Department of Industry and Technology
PO Box 1002
Millersville University
Millersville, PA 17551
717.871.2301
fax: 717.872.3318
thomas.bell@millersville.edu

Region 2 (The nations of Africa, the Caribbean Islands, and the Southeastern United States)
Eric F. Reichard
Department of Technology and Environmental Design
Appalachian State University
Katherine Harper Hall
ASU Box 32122
Boone, NC 28608
Phone: (828) 262-6360
Fax: (828) 265-8696
reichardf@appstate.edu

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Russ College of Engineering
Technology and Management Department
Ohio University
1248 Stecker Center
Athens, OH 45701
740.593.2454
myers22@ohio.edu

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Charles V. Schwab
Iowa State University
Agricultural and Biosystems Engineering Department
220 Industrial Education II
Ames, IA 50011-3130
515.294.4131
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vcschwab@iastate.edu

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Department of Aviation and Technology
San Jose State University
One Washington Square
San Jose, CA 95192
408.924.3218
fax: 408.924.3198
sobp@email.sjsu.edu

Two-Year Institutional Director
(Representing all Community and Technical Colleges)
Karen Woszczyna-Birch
CT Community Colleges
College of Technology/Regional Center for Next Generation Manufacturing
61 Woodland St.
Hartford, CT 06105
860.244.7608
karenlees@bcnet.edu

Executive Director
Kevin B. Howell
Department of Technology
Appalachian State University
Boone, NC 28608
Phone: 828.262.3114

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